





## NOTES/SPECIFICATIONS:

- CLEAR APERTURE: >80% DIAMETER
- SURFACE FLATNESS: λ/10 AT 632.8nm OVER CLEAR APERTURE
- SURFACE QUALITY: 10-5 SCRATCH-DIG
- PARALLELISM: ≤ 3arcmin BACK SURFACE: FINE GROUND
- THICKNESS TOLERANCE: ±0.2mm
- DIAMETER TOLERANCE: +0.0 / -0.1mm DESIGN WAVELENGTH RANGE: 458-528nm
- DURABILITY: MIL-C-675
- 10.

COATING: REFLECTIVE COATING Ravg>99.5% OVER WAVELENGTH RANGE AOI: 45°

FOR INFORMATION ONLY NOT FOR MANUFACTURING PURPOSES

	DRAWING PROJECTION			THORLABS www.thorlabs.com		
		NAME	DATE	Ø 19.0mm Ar Ion MIRROR		
	DRAWN	GG	14/MAR/14	$\lambda = 458-528$ nm, $45^{\circ}$ AOI		
	APPROVAL	DD	18/MAR/14	MATERIAL		REV
	COPYRIGHT © 2014 BY THORLABS			FUSED SILICA		Α
	VALUES IN PARENTHESIS ARE CALCULATED AND MAY CONTAIN ROUNDOFF ERRORS			NB07-J10	APPROX WE	ight g